

Numerical Analysis of Isothermal Gaseous Flows in Microchannel

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Two-dimensional compressible momentum equations were solved by a perturbation analysis and the PISO algorithm to investigate the effects of compressibility and rarefaction on the local flow resistance of isothermal gas flow in circular microchannels. The computations were performed for a wide range of Reynolds numbers and inlet Mach numbers. The explicit expression of the normalized local Fanning friction factor along the microchannel was derived in the present paper. The results reveal that the local Fanning friction factor is a function of the inlet Mach number, the Reynolds number and the length-diameter ratio of the channel. For larger Reynolds and inlet Mach numbers, the friction coefficient in the microchannel is higher than the value in a macrotube, and the gas flow in the microchannel is dominated only by compressibility. For smaller Reynolds and inlet Mach numbers, the Fanning friction factor of gas flow in the microchannel is lower than that in a circular tube of conventional size due to slip flow at the wall and thus, rarefaction has a significant effect on the fluid flow characteristics in a microchannel.

1 Introduction

The rapid development of microchemical (MCS) and microelectromechanic systems (MEMS) has brought up a great interest in understanding the characteristics of flow and heat transfer at a micro scale in the past two decades.

Wu and Little [1] measured the friction factors of nitrogen, argon and helium flow in microchannels with hydraulic diameters ranging from 45.46 to 83.08 μm . They found that these friction factors were much larger than the predictions by the classic theory for laminar flow in conventional channels. Guo and Wu [2] numerically solved the governing equations for compressible flow in a microtube. The results of their calculation showed that the effect of compressibility is important for gaseous flow in microtubes, which causes that the friction coefficients along the tube are larger than the values in a conventional size tube and are no longer constant.

However, Pfahler et al. [3,4] found that for microchannels with hydraulic diameters of 0.98–39.7 μm , the friction factors were lower than those predicted by the classic theory. For a small Reynolds number, the friction constant tends to increase with increasing Reynolds numbers. Choi et al. [5] investigated the flow resistance of nitrogen gas flow in microtubes with hydraulic diameters between 3 and 81 μm and found that the measured friction factors were smaller than those predicted by the classic theory.

Kavehpour et al. [6] and Chen et al. [7] studied the effects of compressibility and rarefaction on gaseous flows in microchannels. Two-dimensional compressible forms of momentum and energy equations were solved with slip velocity and temperature jump boundary conditions in a parallel plate

microchannel. The numerical results revealed that the Nusselt number and the friction coefficient were substantially reduced for slip flows compared with the continuum flows.

As can be seen above, there are inconsistencies in the results of experimental and numerical analyses reported by different researchers. Thus, the motivation of this paper is to numerically analyze the effects of compressibility and rarefaction on the local flow resistance of gas flow in circular microchannels for a wide range of operating conditions.

2 Analysis

2.1 Governing Equations and Numerical Calculation

The isothermal flow of an ideal gas in a circular microchannel is considered. For the laminar steady-state flow, the two-dimensional compressible Navier-Stokes equations expressed in cylindrical coordinate take the following forms:

Continuity:

$$\frac{\partial(\rho u)}{\partial x} + \frac{1}{r} \frac{\partial(\rho r v)}{\partial r} = 0 \quad (1)$$

Momentum:

$$\begin{aligned} \frac{\partial(\rho u u)}{\partial x} + \frac{1}{r} \frac{\partial(\rho r v u)}{\partial r} = & -\frac{\partial P}{\partial x} + \frac{\partial}{\partial x} \left(\mu \frac{\partial u}{\partial x} \right) \\ & + \frac{1}{r} \frac{\partial}{\partial r} \left(\mu r \frac{\partial u}{\partial r} \right) + S_u \end{aligned} \quad (2)$$

$$\begin{aligned} \frac{\partial(\rho u v)}{\partial x} + \frac{1}{r} \frac{\partial(\rho r v v)}{\partial r} = & \\ & -\frac{\partial P}{\partial r} + \frac{\partial}{\partial x} \left(\mu \frac{\partial v}{\partial x} \right) + \frac{1}{r} \frac{\partial}{\partial r} \left(\mu r \frac{\partial v}{\partial r} \right) - \mu \frac{v}{r^2} + S_v \end{aligned} \quad (3)$$

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where

$$S_u = \frac{\mu}{3} \frac{\partial}{\partial x} \left(\frac{\partial u}{\partial x} + \frac{1}{r} \frac{\partial(rv)}{\partial r} \right) \quad S_v = \frac{\mu}{3} \frac{\partial}{\partial r} \left(\frac{\partial u}{\partial x} + \frac{1}{r} \frac{\partial(rv)}{\partial r} \right) \quad (4)$$

In the present paper, the terms S_u and S_v can be omitted in the momentum equation because they are less important than the other terms.

The equation of state for ideal gas is

$$P = \frac{\rho}{M} R_g T \quad (5)$$

The initial and boundary conditions are

$$x = 0, \quad u = 2\bar{u}_{in} \left(1 - \left(\frac{r}{R_0} \right)^2 \right), \quad v = 0 \quad (6)$$

$$x > 0, \quad r = 0, \quad \frac{\partial u}{\partial r} = 0, \quad v = 0 \quad (7)$$

The first-order slip velocity boundary conditions are expressed as

$$r = R_0, \quad u|_{wall} = -\frac{2 - \sigma_v}{\sigma_v} \lambda \frac{\partial u}{\partial r} \Big|_{r=R_0}, \quad v = 0 \quad (8)$$

where σ_v is the tangential momentum accommodation coefficient. This coefficient indicates the influence of rarefaction and fluid-surface interaction. It is thought to vary between 0 and 1 depending on the surface roughness, temperature and gas type. Here, $\sigma_v = 1$ [8].

The Fanning friction factor for the isothermal compressible flow is defined as [9]

$$f_F = \frac{\tau_w}{1/2 \bar{\rho} \bar{u}^2} = \frac{D_h}{2\bar{P}} \left(\frac{d\bar{P}}{dx} \right) - \frac{D_h}{2\bar{\rho} \bar{u}^2} \left(\frac{d\bar{P}}{dx} \right) \quad (9)$$

For fully developed incompressible laminar no-slip flow in a circular tube, the Fanning friction factor is $16/\text{Re}$, so the normalized Fanning friction factor (or coefficient) can be expressed as

$$NC_F = \frac{f_F}{16/\text{Re}} \quad (10)$$

The governing equation of nitrogen flow was solved by a control volume finite-difference scheme and the PISO (pressure implicit split operator) algorithm [10]. The power law scheme was applied to discretize the convective terms in the momentum equation. A grid dependence test using a 60 (radial) \times 400 (axial) uniform staggered grid was performed for the numerical calculation in this study. A line-by-line method was employed to solve the resulting algebraic equations. Alternating sweeps of tridiagonal matrix algorithm combined with a block correction were applied to each variable. The ratio of channel length to diameter was set to be 400. Nitrogen was used as working fluid in the calculation ($\gamma = 1.4$).

2.2 Perturbation Analysis of Governing Equations at Low Reynolds and Mach Number

Arkilic et al. [8] used a perturbation method to analytically solve two-dimensional Navier-Stokes equations with first-order slip boundary conditions for a compressible gas flow in parallel plane microchannels. In this paper, their procedure is followed to investigate the compressible gas flow in circular microchannels, but with a different method in solving the continuity equation and pressure distribution.

The following dimensionless variables are used:

$$\tilde{P} = \frac{P}{P_{in}}, \quad \tilde{\rho} = \frac{\rho}{\rho_{in}}, \quad \tilde{u} = \frac{u}{\bar{u}_{in}}, \quad \tilde{v} = \frac{v}{\bar{u}_{in}}, \quad \tilde{x} = \frac{x}{L}, \quad \tilde{r} = \frac{r}{R_0}, \quad \varepsilon = \frac{R_0}{L}$$

The governing equations can be expressed as

$$\varepsilon \frac{\partial(\tilde{\rho}\tilde{u})}{\partial\tilde{x}} + \frac{1}{\tilde{r}} \frac{\partial(\tilde{\rho}\tilde{r}\tilde{v})}{\partial\tilde{r}} = 0 \quad (11)$$

$$\frac{\text{Re}}{2} \left(\varepsilon \frac{\partial(\tilde{\rho}\tilde{u}\tilde{u})}{\partial\tilde{x}} + \frac{1}{\tilde{r}} \frac{\partial(\tilde{\rho}\tilde{r}\tilde{u}\tilde{v})}{\partial\tilde{r}} \right) = -\frac{\varepsilon \text{Re}}{2\gamma \text{Ma}_{in}^2} \frac{\partial\tilde{P}}{\partial\tilde{x}} + \varepsilon^2 \frac{\partial^2\tilde{u}}{\partial\tilde{x}^2} + \frac{1}{\tilde{r}} \frac{\partial}{\partial\tilde{r}} \left(\tilde{r} \frac{\partial\tilde{u}}{\partial\tilde{r}} \right) \quad (12)$$

$$\frac{\text{Re}}{2} \left(\varepsilon \frac{\partial(\tilde{\rho}\tilde{u}\tilde{v})}{\partial\tilde{x}} + \frac{1}{\tilde{r}} \frac{\partial(\tilde{\rho}\tilde{r}\tilde{v}\tilde{v})}{\partial\tilde{r}} \right) = -\frac{\text{Re}}{2\gamma \text{Ma}_{in}^2} \frac{\partial\tilde{P}}{\partial\tilde{r}} + \varepsilon^2 \frac{\partial^2\tilde{v}}{\partial\tilde{x}^2} + \frac{1}{\tilde{r}} \frac{\partial}{\partial\tilde{r}} \left(\tilde{r} \frac{\partial\tilde{v}}{\partial\tilde{r}} \right) - \frac{\tilde{v}}{\tilde{r}^2} \quad (13)$$

$$\tilde{x} = 0, \quad \tilde{u} = 2(1 - \tilde{r}^2), \quad \tilde{v} = 0 \quad (14)$$

$$\tilde{x} > 0, \quad \tilde{r} = 0, \quad \frac{\partial\tilde{u}}{\partial\tilde{r}} = 0, \quad \tilde{v} = 0 \quad (15)$$

$$\tilde{r} = 1, \quad \tilde{u}|_{\tilde{r}=1} = -2 \frac{2 - \sigma_v}{\sigma_v} \text{Kn} \frac{\partial\tilde{u}}{\partial\tilde{r}} \Big|_{\tilde{r}=1}, \quad \tilde{v} = 0 \quad (16)$$

$$\text{Re} = \frac{D_h \bar{u}_{in} \rho_{in}}{\mu}, \quad \text{Ma}_{in} = \frac{\bar{u}_{in}}{\sqrt{\gamma R_g T / M}}, \quad \text{Kn} = \frac{\text{Kn}_{in}}{\tilde{P}_0}, \quad \text{Kn}_{in} = \sqrt{\frac{\pi \gamma}{2}} \frac{\text{Ma}_{in}}{\text{Re}} \quad (17)$$

Utilizing a perturbation analysis and considering $\varepsilon \ll 1$, $\text{Re} \sim O(\varepsilon)$, $\text{Ma}_{in} \sim O(\varepsilon)$, $\gamma \text{Ma}_{in}^2 / \text{Re} \sim O(\varepsilon)$, the following equation can be obtained from the \tilde{r} momentum equation,

$$\tilde{P}_0 = \tilde{P}_0(x) \quad (18)$$

where the subscript '0' denotes the zero order variables in perturbation expansion. Substituting the above equation into the continuity equation (11), multiplying Eq. (11) by $2\pi \tilde{r}$ and integrating once with respect to \tilde{r} , and then multiplying it by $1/\pi R_0^2$, one can obtain

$$\tilde{P}_0 \tilde{u}_0 = 1 \quad (19)$$

The \bar{x} momentum equation can be expressed as

$$\frac{\varepsilon \text{Re}}{2\gamma Ma_{in}^2} \frac{\partial \tilde{P}_0}{\partial \bar{x}} = \frac{1}{\bar{r}} \frac{\partial}{\partial \bar{r}} \left(\bar{r} \frac{\partial \tilde{u}_0}{\partial \bar{r}} \right) \quad (20)$$

With the boundary conditions in Eqs. (15) and (16), Eq. (20) can be integrated twice with respect to \bar{r} , and then one gets

$$\tilde{u}_0(\bar{x}, \bar{r}) = -\frac{\varepsilon \text{Re}}{8\gamma Ma_{in}^2} \frac{\partial \tilde{P}_0}{\partial \bar{x}} \left(1 + 4 \frac{2 - \sigma_v}{\sigma_v} \frac{Kn_{in}}{\tilde{P}_0} - \bar{r}^2 \right) \quad (21)$$

Multiplying the above equation by $2\pi \bar{r}$ and integrating once with respect to \bar{r} , then multiplying it by $1/\pi R_0^2$, one can obtain

$$\tilde{u}_0(\bar{x}) = -\frac{\varepsilon \text{Re}}{16\gamma Ma_{in}^2} \frac{\partial \tilde{P}_0}{\partial \bar{x}} \left(1 + 8 \frac{2 - \sigma_v}{\sigma_v} \frac{Kn_{in}}{\tilde{P}_0} \right) \quad (22)$$

Substituting Eq. (22) into Eq. (19), will yield

$$\frac{\partial \tilde{P}_0}{\partial \bar{x}} = -\frac{16\gamma Ma_{in}^2}{\varepsilon \text{Re}} \frac{1}{\tilde{P}_0 + 8 \frac{2 - \sigma_v}{\sigma_v} Kn_{in}} \quad (23)$$

Using the initial boundary conditions, $\tilde{P}_0(x)|_{x=0} = 1$, an expression for the pressure distribution can be obtained:

$$\tilde{P}_0(x) = -8 \frac{2 - \sigma_v}{\sigma_v} Kn_{in} + \sqrt{\left(1 + 8 \frac{2 - \sigma_v}{\sigma_v} Kn_{in} \right)^2 - \frac{64}{\text{Re}} \gamma Ma_{in}^2 \frac{L}{D_h} \bar{x}} \quad (24)$$

The Fanning friction factor obtained from is given by

$$f_F(x) = \frac{16}{\text{Re}} \frac{1}{1 + 8 \frac{2 - \sigma_v}{\sigma_v} \frac{Kn_{in}}{\tilde{P}_0(x)}} \quad (25)$$

The normalized Fanning friction factor (or coefficient) can be derived as

$$NC_F(x) = \frac{f_F}{16/\text{Re}} = \frac{1}{1 + 8 \frac{2 - \sigma_v}{\sigma_v} \frac{Kn_{in}}{\tilde{P}_0(x)}} \quad (26)$$

Substituting the pressure distribution equation (24) and Eq. (17) into Eq (26), NC_F can be written as

$$NC_F(x) = \frac{f_F}{16/\text{Re}} = \frac{1}{1 + \frac{8 \frac{2 - \sigma_v}{\sigma_v} \sqrt{\frac{\pi\gamma}{2} Ma_{in}}}{\tilde{P}_0(x)} + \sqrt{\left(1 + 8 \frac{2 - \sigma_v}{\sigma_v} \frac{Kn_{in}}{\tilde{P}_0(x)} \right)^2 - \frac{64}{\text{Re}} \gamma Ma_{in}^2 \frac{L}{D_h} \bar{x}}} \quad (27)$$

So, the explicit expression of the NC_F profile along the channel has been obtained with a method different from that used by Arkilic et al. [8]. As can be seen from the above equations, the local Fanning friction factor is a function of the inlet Mach number, the Reynolds number and the length-diameter ratio of the channel. And for gas flow in the microchannel at low Reynolds and Mach number ($\varepsilon \ll 1$, $Re \sim O(\varepsilon)$, $Ma_{in} \sim O(\varepsilon)$), the operating parameters must obey the following inequation:

$$\frac{64}{\text{Re}} \gamma Ma_{in}^2 \frac{L}{D_h} \bar{x} \leq \left(1 + 8 \frac{2 - \sigma_v}{\sigma_v \sqrt{\frac{\pi\gamma}{2} Ma_{in}}} \right)^2 \quad (28)$$

3 Results and Discussion

3.1 Characteristics of Gas Isothermal Flow in Microchannel

The effects of Ma_{in} on the NC_F profile along the microchannel for different Reynolds numbers are presented in Figs. 1 to 3. The dash lines shown in Figs. 1 and 2 are obtained from Eq. (27).

As illustrated in Figs. 1 and 2, for $Re = 0.05$ and $Re = 10$, $NC_F < 1$, the Fanning friction factor of gas flow in a microchannel is smaller than that in a circular tube with conventional size due to slip flow at the microchannel wall. Thus, rarefaction has a significant influence on the NC_F profile along the microchannel. Also, NC_F decreases with increasing inlet Mach numbers.

It can be seen from Fig. 1 that for small inlet Mach numbers, NC_F remains constant along the streamwise direction, since variations of pressure along the axis of the microchannel are not remarkable. In the case of $Ma_{in} = 0.001$, as the pressure drops along the gas flow direction, the local Knudsen number increases. Since the influence of rarefaction effects and slip flow become more and more significant with increasing local Knudsen numbers, NC_F will decrease along the channel. It is also shown in Fig. 1 that the results of numerical calculations are in good agreement with the solutions derived from Eq. (27) under the same operating conditions.

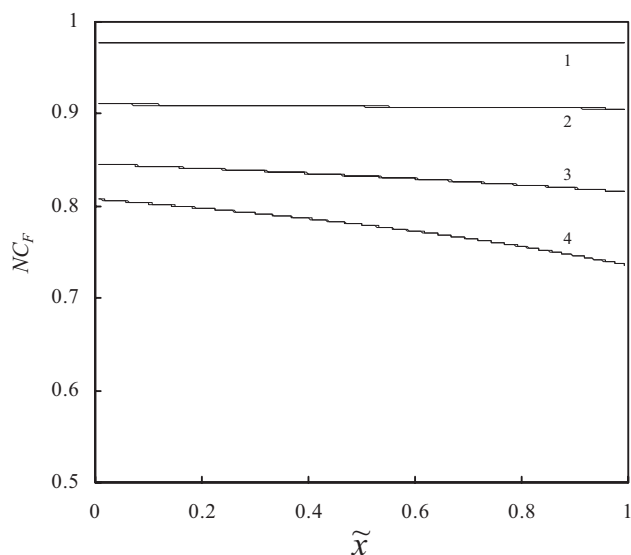


Figure 1. NC_F of N_2 flows as a function of x for inlet Mach numbers Ma_{in} . - Numerical calculation; - - - Eq. (28); Re: 0.05; Ma_{in} : (1) 1×10^{-4} , (2) 4.14×10^{-4} , (3) 7.68×10^{-4} , (4) 10×10^{-4} .

Fig. 2 shows that the influence of inlet Mach number values on the NC_F profile along the channel at $Re = 10$ has the similar trends as that in Fig. 1 for $Re = 0.01$. However, the influence of rarefaction effects and slip flow becomes insignificant with increasing Reynolds number, and the deviation of the Fanning friction factor in the microchannel from that in a circular tube with conventional size tends to reduce as the Reynolds number increases. It is found that the results of numerical calculations are also in good agreement with those calculated from Eq. (27) for $Re = 10$.

The results presented in Fig. 3 show the influence of the inlet Mach number on NC_F as a function of the normalized channel length for $Re = 400$. It is evident that the Fanning friction factor increases with increasing inlet Mach numbers.

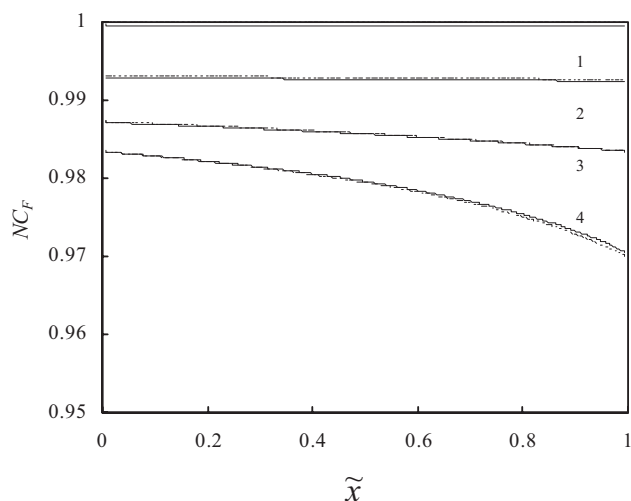


Figure 2. NC_F of N_2 flows as a function of x for inlet Mach numbers Ma_{in} . - Numerical calculation; - - - Eq. (28); Re: 10.0; Ma_{in} : (1) 1×10^{-4} , (2) 5.85×10^{-3} , (3) 0.011, (4) 0.014.

When the inlet Mach number is small, NC_F remains constant along the channel; while for a large inlet Mach number, NC_F increases along the gas flow direction. The results indicate a trend very different from the trends in Figs. 1 and 2, that is, the Fanning friction factor of gas flow in the microchannel is larger than that in conventional size tubes. These phenomena may be caused by the increase of the dimensionless velocity gradient at the wall, a result of the gas acceleration induced by compressibility of gas flow in a long microchannel [2].

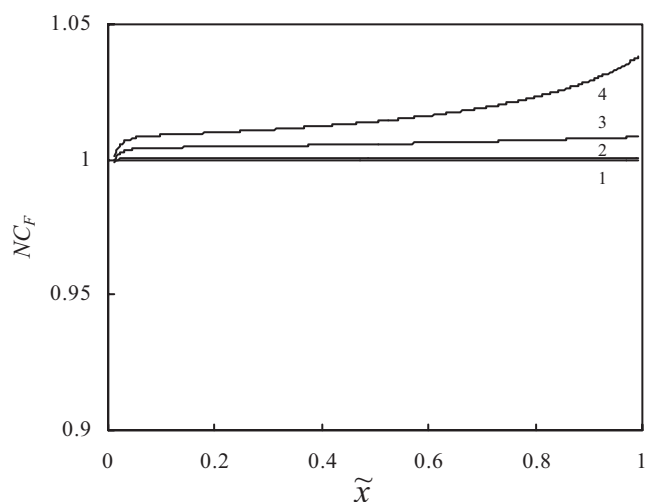


Figure 3. NC_F of N_2 flows as a function of x for inlet Mach numbers Ma_{in} . Re: 400; Ma_{in} : (1) 1×10^{-4} , (2) 0.037, (3) 0.069, (4) 0.09.

3.2 Influence of Operation Conditions on $NC_{F,out}$

It is clearly seen from Figs. 1 to 3 that the influence of the rarefaction effect and compressibility is most remarkable at the outlet of the channel. So, the normalized Fanning friction factor at the outlet of channel, $NC_{F,out}$, can be chosen to represent the influence of the rarefaction effect and compressibility on gas flow in the microchannel.

Fig. 4 shows $NC_{F,out}$ as a function of the inlet Mach number for various Reynolds numbers. As can be seen in this figure, for operating Reynolds numbers smaller than 50, $NC_{F,out} < 1$, and $NC_{F,out}$ decreases with increasing inlet Mach numbers due to more significant rarefaction effects; for operating Reynolds number larger than 50, the rarefaction effect is negligible, the gas flow in the microchannel is controlled only by compressibility, therefore $NC_{F,out} > 1$ and increases with the inlet Mach number.

Fig. 5 shows the influence of the inlet Mach number on $NC_{F,out}$ as a function of the Reynolds number. It is found that, when the inlet Mach number is lower than 0.03, $NC_{F,out}$ increases with the increase of the Reynolds number for a fixed inlet Mach number and finally approaches 1, indicating that gas flow in the microchannel is dominated by rarefaction effects at small inlet Mach number and Reynolds number conditions. However, when the inlet Mach number is

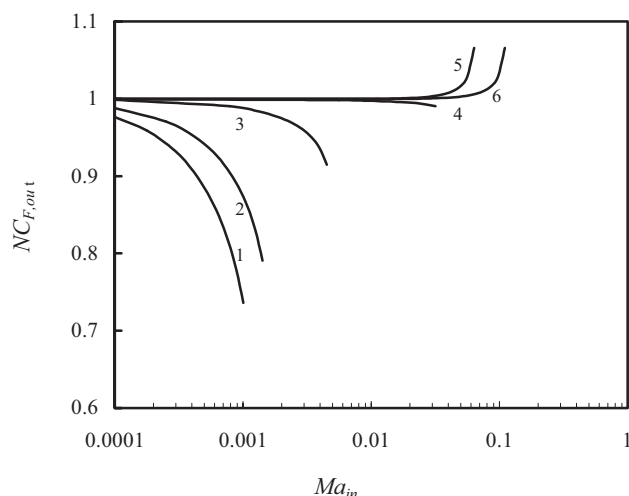


Figure 4. $NC_{F,out}$ of N_2 flows as a function of inlet Mach numbers. Re: (1) 0.05, (2) 0.1, (3) 1.0, (4) 5, (5) 200, (6) 600.

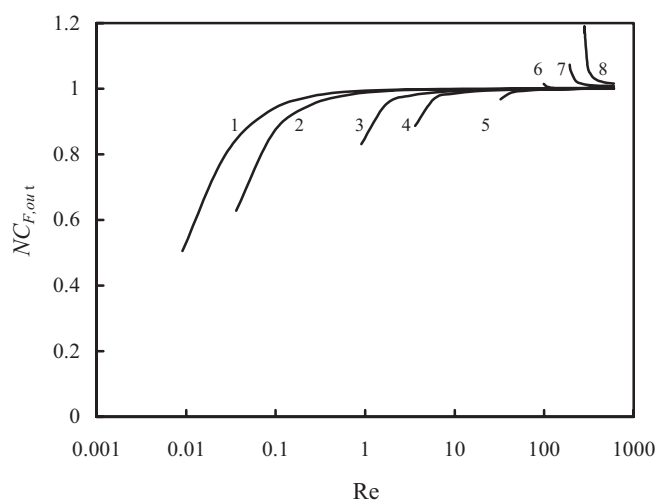


Figure 5. $NC_{F,out}$ of N_2 flows as a function of Re. Ma_{in} : (1) 5×10^{-4} , (2) 0.001, (3) 0.005, (4) 0.01, (5) 0.03, (6) 0.05, (7) 0.07, (8) 0.085.

greater than 0.05, $NC_{F,out} > 1$, $NC_{F,out}$ decreases and also progressively approaches one with raising Reynolds number for a fixed inlet Mach number, thus revealing that the effects of compressibility on gas flow in the microchannel are significant for large inlet Mach numbers and Reynolds numbers.

4 Conclusions

The effects of compressibility and rarefaction on the local flow resistance of isothermal gas flow in circular microchannels for a wide range of operating conditions have been numerically studied in detail. Two-dimensional compressible momentum equations were solved by a perturbation analysis and the PISO algorithm. The explicit expression of the NC_F

profile along the channel was obtained in this paper. It was found that the local Fanning friction factor is a function of the inlet Mach number, the Reynolds number and the length-diameter ratio of the channel.

For a higher Reynolds number and a larger inlet Mach number, the friction coefficient is higher than the value in macrotubes, the gas flow in the microchannel is dominated only by compressibility; while for a lower Reynolds number and a smaller inlet Mach number, the Fanning friction factor of gas flow in the microchannel is smaller than that in a circular tube with conventional size due to slip flow at the microchannel wall, clarifying that rarefaction has a significant effect on fluid flow characteristics.

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Symbols used

C_F	[-]	Fanning friction factor, $C_F = f_F Re$
D_h	[m]	hydraulic diameter ($= 2 R_0$)
f_F	[-]	Fanning friction coefficient
Kn	[-]	Knudsen number
L	[m]	channel length
M	[mol·kg ⁻¹]	gas mole mass
Ma	[-]	Mach number
NC_F	[-]	normalized Fanning friction factor
P	[Pa]	pressure
\tilde{P}	[-]	dimensionless pressure
Pr	[-]	Prandtl number
r	[m]	radial coordinate
\tilde{r}	[-]	dimensionless radial coordinate
R_0	[m]	channel radius
Re	[-]	Reynolds number
R_g	[J·mol ⁻¹ ·K ⁻¹]	gas constant
u	[m·s ⁻¹]	axial velocity
\bar{u}	[m·s ⁻¹]	axial average velocity
\tilde{u}	[-]	axial dimensionless velocity
v	[m·s ⁻¹]	radial velocity
\tilde{v}	[-]	radial dimensionless velocity
x	[-]	axial coordinate
\tilde{x}	[-]	axial dimensionless coordinate

Greek symbols

ρ	$[\text{kg}\cdot\text{m}^{-3}]$	gas density
μ	$[\text{N}\cdot\text{s}\cdot\text{m}^{-2}]$	gas viscosity
σ_v	$[-]$	tangential momentum accommodation coefficient
ε	$[-]$	channel radial/channel length
γ	$[-]$	ratio of specific heats
λ	$[\text{m}]$	mean free path of gas molecules

Subscripts

0,1	zero- or first-order variables for perturbation
in	inlet
wall	channel wall

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